



IPW

In re U.S. Patent Application of

TSUCHIYA et al.

Application Number: 10/750,882

Filed: January 5, 2004

For: METHOD FOR PRODUCING NANOPARTICLE
LAYER HAVING UNIFORM EASY AXIS OF
MAGNETIZATION, MAGNETIC RECORDING
MEDIUM HAVING SUCH LAYER, ITS PRODUCTION
METHOD, AND ITS PRODUCTION APPARATUS

Attorney Docket No. HITA.0482

Honorable Assistant Commissioner
for Patents
Washington, D.C. 20231

COVER LETTER

Sir:

[x] The fee for submission of claims is calculated as shown below:

FOR	TOTAL WITH NEW CLAIMS ADDED	TOTAL CURRENTLY ON FILE	CLAIMS ALREADY PAID	RATE	CALCULATION
Total Claims	22	22	2 (Over 20)	x \$50	0
Independent Claims	4	4	1 (Over 3)	x \$200	0
MULTIPLE DEPENDENT CLAIM(S)				+ \$360	0
REDUCTION FOR FILING BY SMALL ENTITY (note 37,C.F.R. §§ 1.9, 1.27, 1.28).				x ½	
				TOTAL	0.00

In addition, the below-identified communications are submitted in the above-captioned application or proceeding:

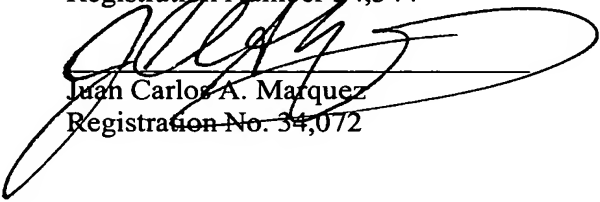
[x] Response to Office Action
(with Claim Election)
[] Substitute Specification
[] Preliminary Amendment
[] Information Disclosure Statement

[] Petition for Extension of Time
[] Terminal Disclaimer
[] Letter to Draftsperson
[] Assignment
[] Other _____

- [] Please charge my **Deposit Account Number** _____ in the amount of _____ to cover the fees for _____. A duplicate copy of this paper is enclosed.
- [] A check in the amount of **\$0.00** to cover the _____ fee is enclosed.
- [x] The Commissioner is hereby authorized to charge any additional fees associated with this communication, including fees under 37 C.F.R. § 1.16 and 1.17, or credit any overpayment to **Deposit Account Number 08-1480**.

Respectfully submitted,

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October 21, 2005



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent Application of)
)
TSUCHIYA et al.) **Art Unit 1773**
)
Application Number: 10/750,882) **Examiner Stevan A. Resan**
)
Filed: January 5, 2004)
)
For: METHOD FOR PRODUCING NANOPARTICLE)
LAYER HAVING UNIFORM EASY AXIS OF)
MAGNETIZATION, MAGNETIC RECORDING)
MEDIUM HAVING SUCH LAYER, ITS PRODUCTION)
METHOD, AND ITS PRODUCTION APPARATUS)
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Attorney Docket No. HITA.0482)

**Honorable Assistant Commissioner
for Patents
Washington, D.C. 20231**

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

This is in response to the Office Action mailed on September 26, 2005, the period of response to which is set to expire on October 26, 2005. Applicants hereby elect the continuing prosecution of Group I as recited in claims 1 - 9, drawn to an article, classified in class 428, subclass 842.2, without traverse.